

<b>Notice of References Cited</b>	Application/Control No. 10/029,394	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Khiem D. Nguyen	Art Unit 2823	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0026968	10-2001	Sung et al.	438/200
*	B	US-2003/0206447	11-2003	Tuan et al.	365/185.33
*	C	US-2002/0000602	01-2002	Lee, Robin	257/314
*	D	US-5,981,403	11-1999	Ma et al.	438/758
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

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